



MIT9922

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Menon et al. **GROUP:** 2881
SERIAL NO: 10/624,316 **EXAMINER:** Berman, Jack I.
FILED: 07/21/2003
FOR: SYSTEM AND METHOD FOR MASKLESS LITHOGRAPHY USING
AN ARRAY OF IMPROVED DIFFRACTIVE FOCUSING ELEMENT

Mail Stop Non-Fee Amendment
Assistant Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

Responsive to the Office Action mailed on July 14, 2004, please amend the above-identified application as follows: